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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Eran Dvir, Moshe Finarov, Eli Haimovich, and Benjamin Shumel  
Assignee: Nova Measuring Instruments Ltd.  
Title: APPARATUS FOR OPTICAL INSPECTION OF WAFERS DURING POLISHING

Serial No.: 08/497,382 Filed: June 29, 1995  
Examiner: E. Morgan Group Art Unit: 3203  
Batch No.: U26 Allowed: November 17, 1997  
Docket No.: M-3417 US

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**INFORMATION DISCLOSURE STATEMENT  
WITH CERTIFICATION UNDER § 1.97(e)(1)  
WITH PETITION**

Sir:

Pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98, Applicant(s) wish to call the following documents (copies enclosed) to the attention of the Examiner. The documents were

cited in the 1997 Office Action for the corresponding Israeli Application No.

113829

1. USP 4,793,895 issued 12/27/88 to Kaanta et al.
2. USP 5,157,877 issued 10/27/92 to Hashimoto.
3. USP 5,240,552 issued 08/31/93 to Yu et al.
4. USP 5,337,015 issued 08/09/94 to Lustig et al.

A PTO form 1449 listing these documents is enclosed.

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Citation of the above documents shall not be construed as:

1. an admission that the documents are necessarily prior art with respect to the instant invention;
2. a representation that a search has been made, other than as described above; or
3. an admission that the information cited herein is, or is considered to be, material to patentability as defined in § 1.56(b).

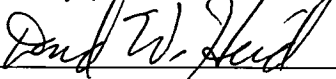
The undersigned hereby certifies in accordance with § 1.97(e)(1) that each item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this information disclosure statement.

In view of the status of subject application, pursuant to 37 CFR 1.97(d), Applicant(s) hereby request(s) consideration of this Information Disclosure Statement With Certification Under §1.97(e)(1).

The Petition fee of \$130.00 under 37 CFR §1.17(i)(1) is proffered hereby. Please charge such Petition fee (plus any other fees which may be required) to Deposit Account No. 19-2386. This paper is being submitted in triplicate.

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231,

on February 5, 1998.

  
Attorney for Applicant(s)

5 Feb 98  
Date of Signature

Respectfully submitted,



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